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PATENT

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Charles W. Pearce

Serial No.: 09/755,826

Filed: January 4, 2001

Title: A METHOD OF MANUFACTURING A LATERALLY DIFFUSED METAL OXIDE SEMICONDUCTOR DEVICE

Grp./A.U.: 2813

Examiner: Chen, Jack S.

Honorable Commissioner of Patents
Washington, D.C. 20231

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner of Patents and Trademarks, Washington, D.C.

20231, on 1-23-2003 (Date)

Elizabeth Schumacher

(Printed or typed name of person signing the certificate)

Elizabeth Schumacher

(Signature of the person signing the certificate)

Sir:

AMENDMENT UNDER 37 C.F.R. § 1.111

In response to the Examiner's Action mailed October 24, 2002, please amend the above-identified application as follows:

IN THE CLAIMS:

(1) Kindly rewrite Claim 6 as follows:

6. (Amended) The method as recited in Claim 5 wherein diffusing the second dopant includes diffusing a P-type dopant having an implant dose ranging from about 1E13 atoms/cm² to about 1E14 atoms/cm².

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JAN 30 2003
TECHNOLOGY CENTER 2800

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